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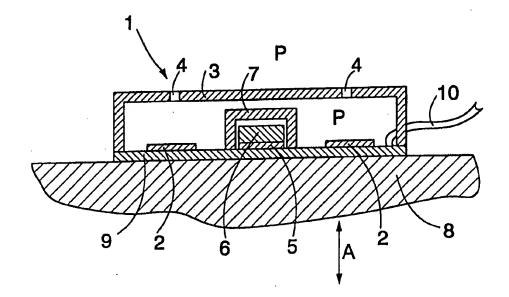
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(57) Abstract

The invention relates to a sensor for measuring acceleration and sound pressure, the sensor comprising means for measuring pressure (P) and means for measuring acceleration. The means for measuring pressure (P) and acceleration are arranged concentrically in the same plane, the pressure (P) and acceleration being measured at exactly the same point, and e.g. a phase shift not being able to cause error in the measurement result.

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SENSOR FOR MEASURING ACCELERATION AND SOUND PRESSURE

The invention relates to a sensor for measuring acceleration and sound pressure, the sensor separately comprising means for measuring the acceleration of a surface and means for measuring the sound pressure affecting the surface.

Extremely accurate values of the magnitudes of the acceleration and the pressure affecting a surface are needed e.g. in an application which actively attenuates sound and oscillation caused by noise. Said values are needed for controlling the means, i.e. actuators, generating counter-oscillation. Since the signals to be measured are wave-formed, completely reliable measurement results are extremely difficult to obtain, since a phase difference can be present at the time of measurement in two different measurements, the phase difference excessively interfering with the final result.

German Publication No. 4,342,169 discloses an electromechanical transformer operating as e.g. a microphone. Said transformer comprises a film for emitting a signal which is proportional to the sound pressure and/or surface acceleration. However, the transformer cannot be used in accurate sound attenuation applications since the sound pressure and acceleration signals cannot be distinguished one from the other.

It is the object of the present invention to provide a sensor for measuring acceleration and sound pressure accurately and reliably.

The sensor of the invention is characterized in that the means for measuring the acceleration and the means for measuring the sound pressure are arranged substantially concentrically and substantially in the same plane.

An essential idea of the invention is that the means for measuring acceleration and the means for measuring sound pressure are arranged concentrically in the same plane. The idea of a preferred embodiment is that the means for measuring pressure is circular and the means for measuring acceleration is arranged in the middle of said circle. The pressure sensor is most preferably formed of pressure-sensitive film having flat gas bubbles and a metal coating on at least one side, a permanent electric charge being formed in the film, the sensor emitting an electric signal proportional to the pressure. Furthermore, the acceleration sensor is preferably made of similar material by adding a mass on top of it and arranging the acceleration sensor in such a way that pressure changes do not affect it, but the movement of the surface to be measured causes the mass disposed upon the material to emit a signal.

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It is an advantage of the invention that one of the measuring means, arranged concentrically in the same plane, measures pressure and the other measures acceleration from the same place at the same time, whereby no error caused by a phase error can affect the measurement result, i.e. the measurement is reliable and accurate. When the same material is mainly used in the acceleration and pressure measurement sensors, the sensor production technique becomes easy. By arranging the acceleration sensor such that a mass is placed on the pressure-sensitive film, the resulting acceleration sensor is not substantially affected by lateral movements.

The invention will be described in more detail in the attached drawings, in which

Figure 1 is a schematic sectional side view the sensor of the invention, and

Figure 2 is a top view of the sensor of Figure 1.

Figure 1 shows a sensor 1 for measuring acceleration and sound pressure. The means for measuring the sound pressure is a pressure-sensitive film 2. The film 2 comprises flat gas bubbles and has a metal coating on at least one side, and a permanent electric charge, i.e. what is known as an electret charge, is formed in it. As pressure P affects said film, the film emits an electric signal proportional to the pressure, i.e. it is a capacitive sensor. The mass of the film 2 is so small that its movement does not substantially generate a signal, essentially all signals being generated by a change in the pressure P affecting the film 2. The film 2 is encased in a housing 3 provided with holes 4 through which pressure changes, i.e. in practice, changes in sound pressure, affect the film 2.

The film 2 is circular and the means for measuring acceleration are arranged in its midpoint. The means for measuring acceleration comprise a pressure-sensitive film 5 and a mass 6 disposed on top of the film. The film 5 is of similar material as the film 2. The film 5 and the mass 6 are encased in a protective casing 7 for preventing a change in sound pressure from affecting the film 5. Consequently, substantially only the weight of the mass 6 affects the film 5, whereby with the surface of a body 8 moving in the direction shown by arrow A, the weight of the mass 6 affects the film 5, whereby the acceleration of the surface of the body 8 in the directions of arrow A can be measured. The protective casing 7 may comprise very small holes or pores through which the air pressure inside the protective casing 7 is allowed to even out, the holes

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or pores being so small that the sound pressure P cannot affect the film. The acceleration sensor of Figure 1 is not substantially affected by lateral acceleration. The acceleration sensor and the sound pressure sensor are separate, allowing the sound pressure and surface acceleration to be measured separately. Furthermore, the acceleration sensor and the sound pressure sensor are substantially in the same plane.

The films 2 and 5 and the housing 3 and the protective casing 7 are secured to a base plate 9. Microcircuits for amplifying signals, for example, can be arranged in the base plate 9. The measured signals are led via a connecting wire 10 to be further utilized. The base plate 9 may also be of silicon substrate, whereby a circuit comprising the electronics necessary for signal processing can be integrated therein. The electronics of the sensor 1 can also be adapted to form the mass 6.

The sensor can be dimensioned very small, e.g. with a diameter of about 10 mm or even less and a thickness of e.g. about 1 mm or even less. Since the film 5 is very light and sensitive, the mass 6 does not have to be heavy, but a mass of e.g. 0.1 g or less is adequate.

Figure 2 is a top view of the sensor of Figure 1. The numbering of Figure 2 corresponds to that of Figure 1. For the sake of clarity, the housing 3, the protective casing 7, and the mass 6 are not shown in Figure 2. As can be seen from Figure 2, the film 2 is annular and the film 5 is arranged substantially in its middle.

Acoustic surface intensity measurements are important applications of the sensor 1. A velocity signal is achieved from the measured acceleration signal by integration in a manner fully known per se. Said integration can be included in the electronics part of the sensor 1, if desired.

The drawing and the related description are only intended to illustrate the inventive idea. As to its details, the invention may vary within the scope of the claims. Consequently, the means for measuring acceleration and pressure may be any kind of means known per se, as long as they are arranged concentrically in the same plane. The sensor may also be constructed by arranging the means for measuring pressure in the middle and the means for measuring acceleration e.g. in the shape of a ring around them. However, the preferable way to carry out the measurements has been described above. The sensor can be micromechanically made on silicon. The sensor can, of course, be used e.g. only as a microphone or a mere acceleration sensor.

CLAIMS

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- 1. A sensor for measuring acceleration and sound pressure, the sensor (1) separately comprising means for measuring the acceleration of a surface and means for measuring the sound pressure (P) affecting the surface, **characterized** in that the means for measuring the acceleration and the means for measuring the sound pressure (P) are arranged substantially concentrically and substantially in the same plane.
- 2. A sensor as claimed in claim 1, characterized in that the means for measuring pressure is annular and the means for measuring acceleration is disposed substantially in its middle.
- 3. A sensor as claimed in claim 1 or 2, c h a racterized in that the means for measuring pressure comprises a pressure-sensitive film (2) having flat gas bubbles and a metal coating on at least one side, and in which a permanent electric charge has been formed.
- 4. A sensor as claimed in any one of the preceding claims, c h a r-acterized in that the means for measuring acceleration comprises a pressure-sensitive film (5) having flat gas bubbles and a metal coating on at least one side, and in which a permanent electric charge has been formed, a mass (6), arranged on top of the film (5), and a protective casing (7) arranged around the film (5) and the mass (6) in order for sound pressure (P) not to be able to substantially affect the film (5).
- 5. A sensor as claimed in any one of the preceding claims, c h a r a c t e r i z e d in that the sensor (1) comprises the electronics needed for signal processing.
- 6. A sensor as claimed in claim 5, **characterized** in that the sensor (1) comprises a base plate (9) into which a circuit containing the electronics needed for signal processing is integrated.

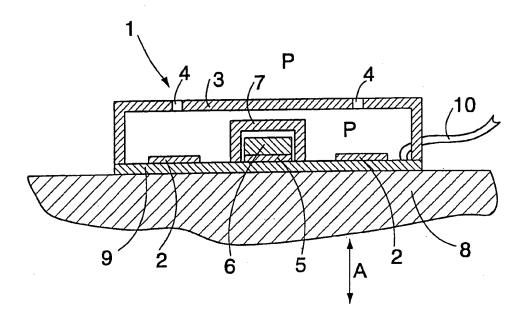


FIG. 1

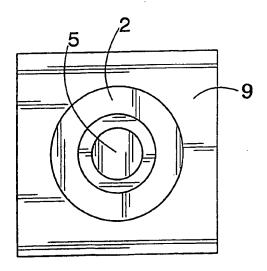


FIG. 2

INTERNATIONAL SEARCH REPORT

International application No.

PCT/FI 97/00706

A. CLASS	IFICATION OF SUBJECT MATTER		* 12 DO
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Category*	Citation of document, with indication, where app	ropriate, of the relevant passages	Relevant to claim No.
A	US 4654546 A (K. KIRJAVAINEN), 3 (31.03.87), column 4, line 3	1 March 1987 3 - line 65, figure 5A	1-6
A	SU 1808024 A3 (V.V. KOLOSOV), 7 (07.04.93), figure 1, abstra		1-6
A	DE 4410794 A1 (ADS MESSTECHNIK G 5 October 1995 (05.10.95), f abstract	MBH), igures 1,2,	1-6
A	Patent Abstracts of Japan, Vol 9 JP 8-184608 A (NIPPONDENSO 0 (16.07.96)	06,No 7 abstract of CO LTD), 16 July 1996	1-6
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C (Continu	nation). DOCUMENTS CONSIDERED TO BE RELEVANT	
Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No
A	DE 4342169 A1 (SENNHEISER ELECTRONIC KG), 14 June 1995 (14.06.95), figures 1-9, abstract	1-6
A	GB 2235533 A (STC PLC), 6 March 1991 (06.03.91), figures 1,2, abstract	1-6
` A	US 5519637 A (G. MATHUR), 21 May 1996 (21.05.96), figures 3,4, abstract	1-6
A	US 5434371 A (L.E. BROOKS), 18 July 1995 (18.07.95), figures 1-5, abstract	1-6
A	US 5325437 A (K. DOI ET AL.), 28 June 1994 (28.06.94), figures 1-4, abstract	1-6

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cited in search report		date	member(date		
US	4654546	A	31/03/87	DK 53368 EP 018276 SE 018276 JP 183272 JP 6114804	64 A,B 64 T3 21 C	21/05/86 28/05/86 29/03/94 05/07/86
SU	1808024	АЗ	07/04/93	NONE		
DE	4410794	A1	05/10/95	NONE		
DE	4342169	A1	14/06/95	NONE		
GB	2235533	A	06/03/91	NONE		
US	5519637	Α	21/05/96	NONE		
US	5434371	A	18/07/95	AU 168569 EP 074293 JP 950872 WO 952143	33 A 29 T	21/08/95 20/11/96 02/09/97 10/08/95
US	5325437	Α	28/06/94	DE 424410 JP 518148		01/07/93 23/07/93

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